AMENDMENTS TO THE CLAIMS:

Claim 1. (Currently Amended) A group III nitride compound semiconductor lightemitting device, comprising:

a semiconductor laminate portion including a light-emitting layer; and a reflection surface disposed so as to be opposite to a side surface of said <u>light-emitting layer semiconductor laminate portion</u>,

wherein said semiconductor laminate portion and said reflection surface are provided in one and the same chip.

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- Claim 2. (Original) A group III nitride compound semiconductor light-emitting device according to claim 1, wherein said reflection surface reflects light from said side surface of said semiconductor laminate portion into a direction of an optical axis of said light-emitting device.
- Claim 3. (Original) A group III nitride compound semiconductor light-emitting device according to claim 1, wherein a distance between said reflection surface and said side surface of said semiconductor laminate portion is in a range of from 0.1 to $10\mu m$.
- Claim 4. (Currently Amended) A group III nitride compound semiconductor lightemitting device according to claim 1, wherein said reflection surface <u>comprises</u> is made of a material which is the same as that of an n pad electrode.
- Claim 5. (Original) A group III nitride compound semiconductor light-emitting device according to claim 4, wherein a portion of said n pad electrode opposite to said side surface of said semiconductor laminate portion from a second reflection surface.
- Claim 6. (Currently Amended) A group III nitride compound semiconductor lightemitting device according to claim 4, wherein said reflection surface is formed on an n-type semiconductor layer which is formed by etching to be a first depth, and said n pad electrode is

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formed on said n-type semiconductor layer which is formed by etching to be a second depth shallower than said first depth.

- Claim 7. (Original) A group II nitride compound semiconductor light-emitting device according to claim 4, wherein said reflection surface is formed integrally with said n pad electrode.
- Claim 8. (Currently Amended) A group III nitride compound semiconductor lightemitting device, comprising:
- a <u>plurality</u> laminate of group III nitride compound semiconductor layers <u>comprising</u> inclusive of a light-emitting layer;
- a groove formed in said <u>plurality of group III nitride compound semiconductor layers</u> laminate; and
- a reflection surface formed on an outer side surface of said groove, said reflection surface being disposed opposite to a side surface of said light-emitting layer.
- Claim 9. (Original) A group III nitride compound semiconductor light-emitting device according to claim 8, wherein said groove is formed by a dicing saw.
- Claim 10. (Currently Amended) A group III nitride compound semiconductor lightemitting device according to claim 8, wherein said reflection surface <u>comprises</u> is made of a metal layer.
- Claim 11. (Currently Amended) A group III nitride compound semiconductor lightemitting device according to claim 10, wherein said metal layer <u>comprises</u> is made of a material which is the same as that of an n pad electrode, and said metal layer is formed at the same time when said n pad electrode is formed.
- Claim 12. (Original) A group III nitride compound semiconductor light-emitting device according to claim 8, wherein light emitted from a side surface of said laminate is reflected by said reflected surface in a direction of an optical axis of said light-emitting device.



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Claim 13. (Currently Amended) A group nitride compound semiconductor light-emitting device according to claim 8, wherein <u>said plurality of group III nitride compound</u> semiconductor layers further comprises a <u>substrate</u>, a bottom of said groove <u>being defined by said has a depth to reach a substrate</u>.

Claim 14. (Original) A group III nitride compound semiconductor light-emitting device according to claim 8, wherein said groove is substantially parallel to a chip cutting line.

Claim 15. (New) A group III nitride compound semiconductor light-emitting device according to claim 1, wherein a distance between said reflection surface and said side surface of said semiconductor laminate portion is in a range of 0.2 μ m to 7 μ m.

Claim 16. (New) A group III nitride compound semiconductor light-emitting device according to claim 1, wherein a distance between said reflection surface and said side surface of said semiconductor laminate portion is in a range of 0.3 μ m to 5 μ m.

Claim 17. (New) A group III nitride compound semiconductor light-emitting device according to claim 1, wherein said reflection surface is formed on a layer in said semiconductor laminate portion.

Claim 18. (New) A group III nitride compound semiconductor light-emitting device according to claim 1, wherein an upper surface of said reflection surface is elevated higher than said light-emitting layer.

Claim 19. (New) A group III nitride compound semiconductor light-emitting device according to claim 1, wherein said reflection surface comprises a curved reflection surface.

Claim 20. (New) A group III nitride compound semiconductor light-emitting device according to claim 8, wherein a width of said groove is in a range of 3 μ m to 50 μ m.

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Claim 21. (New) A group III nitride compound semiconductor light-emitting device according to claim 8, wherein a width of said groove is in a range of 7 μ m to 40 μ m.

Claim 22. (New) A group III nitride compound semiconductor light-emitting device according to claim 1, wherein at least a portion of said reflector surface lies in a same plane as a portion of said light-emitting layer.